| Notice of References Cited | Application/Control No. 10/517,483 | Applicant(s)/Patent Under Reexamination KAULE, WITTICH | | |
|----------------------------|------------------------------------|--|-------------|--|
| | Examiner | Art Unit | Page 1 of 1 | |
| | Arnel C. Lavarias | 2872 | | |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|----------------|----------------|
| * | Α | US-5,101,297 | 03-1992 | Yoshida et al. | 359/566 |
| | В | US- | | | |
| | U | US- | | | |
| | ם | US- | | | |
| | ш | US- | | | |
| | F | US- | | | |
| | O | US- | | | |
| | Ι | US- | | | |
| | _ | US- | | | |
| | ٦ | US- | | | |
| | K | US- | | | |
| | ┙ | US- | | | |
| | М | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|-------------------|----------------|
| | Ν | JP 09230122 A | 09-1997 | Japan | TAKAHASHI, SUSUMU | |
| | 0 | | | | | |
| | Ρ | | | | | |
| | σ | | | | | |
| | R | | | | | |
| | S | | | | | |
| | ۲ | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
| | U | |
| | ٧ | |
| | W | |
| | × | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.